

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Min-hwa Chi

Serial No. not yet assigned

Filed: 5/24/01

For: TRANSISTOR AND LOGIC CIRCUIT
ON THIN SILICON-ON-INSULATOR WAFERS
BASED ON GATE INDUCED DRAIN
LEAKAGE CURRENTS

Examiner: D. Kang

Art Unit: 2811

#2/101 Amel A
Amel
8/2/01

Assistant Commissioner for Patents
Washington, DC 20231

PRELIMINARY AMENDMENT

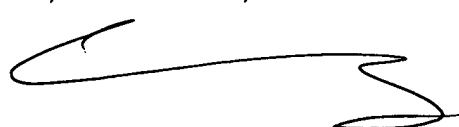
Sir or Madam:

Prior to examination of the above referenced application, Applicant
respectfully request the Examiner to cancel Claims 1-10 and 19-26.

Respectfully submitted,

BLAKELY, SOKOLOFF, TAYLOR and ZAFMAN

Dated: 5/24/01


Chun M. Ng
Reg. No. 36,878